	Uital	Search Text	DB	Time stamp
L Number	Hits		USPAT;	2004/08/23 17:23
1	2	6674350.pn.	US-PGPUB;	
	:		EPO; JPO;	
			DERWENT	
		The second secon	USPAT;	2004/08/23 17:23
2	7898	electromagnetic adj actuator	US-PGPUB;	2004,00,23 1:120
			EPO; JPO;	
	i		i i	l l
			DERWENT	2004/08/23 17:24
3	32570	movable adj member	USPAT;	2004/00/23 17.24
			US-PGPUB;	[
			EPO; JPO;	
			DERWENT	2004/08/23 17:25
4	221090	plating	USPAT;	2004/08/23 17.23
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	2004/00/22 17:25
5	351	station adj member	USPAT;	2004/08/23 17:25
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	1
6	0	(electromagnetic adj actuator) and	USPAT;	2004/08/23 17:26
] ~		(movable adj member) and (station adj	US-PGPUB;	1
		member)	EPO; JPO;	
			DERWENT	
1 7	290	(electromagnetic adj actuator) and	USPAT;	2004/08/23 17:26
'	250	(movable adj member)	US-PGPUB;	
		(movable da) membel/	EPO; JPO;	
			DERWENT	
	114581	silicon adj substrate	USPAT;	2004/08/23 17:26
8	114201	Silicon adj Subscrace	US-PGPUB;	
			EPO; JPO;	
			DERWENT	
	,	((electromagnetic adj actuator) and	USPAT;	2004/08/23 17:36
9	/	(movable adj member)) and (silicon adj	US-PGPUB;	
			EPO; JPO;	
		substrate)	DERWENT	
		4425020224 426106724 445271394	USPAT	2004/08/23 17:28
10	9			
		"4857781" "5107372" "5647311"		
		"5724015" "6014240" "6054329").PN.	USPAT;	2004/08/23 17:36
11	11915	stationary adj member	US-PGPUB;	2301,00,20
			EPO; JPO;	
			DERWENT	
			USPAT;	2004/08/23 17:37
13	114581	silicon adj substrate	US-PGPUB;	2004/00/23 1:00
			EPO; JPO;	
			DERWENT	
			ļ -	2004/08/23 17:37
14	3		USPAT;	2004/00/25 1/.5/
		(movable adj member) and (stationary adj	US-PGPUB;	
		member)) and (silicon adj substrate)	EPO; JPO;	
		_	DERWENT	2004/08/23 18:04
12	25	(electromagnetic adj actuator) and	USPAT;	2004/00/23 10:04
		(movable adj member) and (stationary adj	US-PGPUB;	
		member)	EPO; JPO;	
			DERWENT	2004/00/22 10:05
15	221090	plating	USPAT;	2004/08/23 18:05
			US-PGPUB;	
	}		EPO; JPO;	
-			DERWENT	0004/00/00 10 05
16	69889	photolithography	USPAT;	2004/08/23 18:05
10			US-PGPUB;	
			EPO; JPO;	
			DERWENT	
17	7464	plating and photolithography	USPAT;	2004/08/23 18:05
* '	""		US-PGPUB;	
			EPO; JPO;	
			DERWENT	
			1	

18	3	(plating and photolithography) and	USPAT;	2004/08/23 18:06
	İ	(stationary adj member) and (silicon adj	US-PGPUB;	
	1	substrate)	EPO; JPO;	
	į		DERWENT	
19	22	(plating and photolithography) and	USPAT;	2004/08/23 18:25
		(electromagnetic adj actuator)	US-PGPUB;	
	ļ		EPO; JPO;	
			DERWENT	
20	2	("4421381" "5378653").PN.	USPAT	2004/08/23 18:07
21	4	("4421381" "4937226" "5116457"	USPAT	2004/08/23 18:13
		"5767666").PN.		[
22	2	("4421381" "5378653").PN.	USPAT	2004/08/23 18:13
23	4	("4421381" "4937226" "5116457"	USPAT	2004/08/23 18:14
		"5767666").PN.		
24	4	("4421381" "4937226" "5116457"	USPAT	2004/08/23 18:16
		"5767666").PN.		
25	194	29/595.ccls.	USPAT;	2004/08/23 18:26
			US-PGPUB;	
]			EPO; JPO;	
			DERWENT	
26	3012	29/596.ccls.	USPAT;	2004/08/23 18:26
			US-PGPUB;	
	1		EPO; JPO;	ļ
			DERWENT	
27	4	29/595.ccls. and 29/596.ccls.	USPAT;	2004/08/23 18:26
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	
28	483	324/97.ccls.	USPAT;	2004/08/23 18:26
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	
29	1782	324/96.ccls.	USPAT;	2004/08/23 18:27
			US-PGPUB;	1
			EPO; JPO;	
			DERWENT	0001/00/00 10 07
30	16	324/97.ccls. and 324/96.ccls.	USPAT;	2004/08/23 18:27
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	2004/00/22 10:07
31	240	335/256.ccls.	USPAT;	2004/08/23 18:27
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	2004/08/23 18:27
32	584	335/220.ccls.	USPAT;	2004/00/23 10:2/
			US-PGPUB;	
			EPO; JPO;	
	į	1 225 (222	DERWENT	2004/08/23 18:28
33	3	335/256.ccls. and 335/220.ccls.	USPAT;	2004/00/23 10.28
			US-PGPUB;	
	}		EPO; JPO;	
			DERWENT	2004/08/23 18:29
34	26	334/2.ccls.	USPAT;	2004/00/25 10.29
			US-PGPUB;	-
			EPO; JPO;	**************************************
			DERWENT	2004/08/23 18:29
35	584	335/220.ccls.	USPAT;	2004/00/23 10.29
			US-PGPUB;	1
			EPO; JPO;	İ
			DERWENT	

1	L Number	Hits	Search Text	DB	Time stamp
2 . 7898 electromagnetic adj actuator				USPAT;	
2 7898 electromagnetic adj actuator	*	_	o o contract plant	US-PGPUB;	
2 . 7898 electromagnetic adj actuator USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPAT; USPACEUB: EPO; JPO; DERWENT USPACE				EPO; JPO;	
3 12570 movable adj member movable adj memb				DERWENT	
32570 movable adj member	2	7898	electromagnetic adj actuator	USPAT;	2004/08/23 17:23
3 32570 movable adj member DERMENT US-PGPUB; EPG; JPO; JPO; DERMENT US-PGPUB; EPG; JPO; JPO; JPO; JPO; JPO; JPO; JPO; JPO	٠		3	US-PGPUB;	
32570 movable adj member USPAT;				EPO; JPO;	
1		İ		DERWENT	
4 221090 plating	3	32570	movable adj member	USPAT;	2004/08/23 17:24
221090 plating DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; US-PGFUB; Pepc, JPG, DEMMENT USPAT; USP				US-PGPUB;	
221090 Plating USPAT; 2004/08/23 17:25 USPAT; 2004/08/23 17:26 USPAT; USPAT; 2004/08/23 17:26 USPAT; USPAT; USPAT; 2004/08/23 17:26 USPAT; USPAT]			EPO; JPO;	
Second S				DERWENT	
September Sept	4	221090	plating	USPAT;	2004/08/23 17:25
Station adj member DERMENT USPAT;				US-PGPUB;	
351 Station adj member USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; US-PCPUB; EPO; JPO; DERWENT USPAT; USPAC; USPAPT; USPAT; USPAT; USPAT; USPAT; USPAT; USPAT; USPAC; USPAPT; USPAT; USPAC; USPAPT; USPAT; USPAC; USPAPT; USPAT; USPAC; USPAPT;				EPO; JPO;	
Comparison of the content of the c				DERWENT	
Comparison of the companies of the com	5	351	station adj member	USPAT;	2004/08/23 17:25
Carry Carr]	'		US-PGPUB;	
6 0 (electromagnetic adj actuator) and (movable adj member) and (station adj US-PGPUB; EPO; JPO; DERWENT US-PGPUB; EPO; JPO; JPO; DERWENT US-PGPUB; EPO; JPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWE				EPO; JPO;	
(movable adj member) and (station adj member) 2004/08/23 17:26 2004/08/23 18:05 2				DERWENT	
(movable adj member) and (station adj US-PCPUB; member) (movable adj member) (movable adj actuator) and (movable adj member)	6	0	(electromagnetic adj actuator) and	USPAT;	2004/08/23 17:26
The second color of the	-		(movable adi member) and (station adi	US-PGPUB;	
290 (electromagnetic adj actuator) and USPAT; US-PGPUB; EPO; JPO; DERMENT USPAT;				EPO; JPO;	İ
290	<u> </u>				
S	1 7	290	(electromagnetic adi actuator) and	USPAT;	2004/08/23 17:26
8 114581 silicon adj substrate	'	250		US-PGPUB;	1
8				EPO; JPO;	
9 7 ((electromagnetic adj actuator) and (movable adj member)) and (silicon adj substrate) 10 9 ("3503022" "3619673" "4527139" USPAT; USPAC; USPAT; US		:		DERWENT	
10 9 ("3503022" "3619673" "4527139" USPAT; USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; USP		114581	 silicon adi substrate	USPAT;	2004/08/23 17:26
10	0	114501	Jilleon day basselass	US-PGPUB;	
10	}			ł i	
(movable adj member) and (silicon adj substrate) ("3503022" "3619673" "4527139" USPAT USPAT 2004/08/23 17:28				DERWENT	
(movable adj member) and (silicon adj substrate)		7	((electromagnetic adi actuator) and	USPAT;	2004/08/23 17:36
Substrate SEO; JPO; DERWENT "3503022" "3619673" "4527139" USPAT USPAT 2004/08/23 17:28 11		,	(movable adi member)) and (silicon adi	US-PGPUB;	
10				EPO; JPO;	
"4857781" "5107372" "5647311" "5724015" "6014240" "6054329").PN. stationary adj member "195724015" "502408,23 17:36 "1967247 US-PGPUB; EPO; JPO; DERWENT USPAT; US-PG				DERWENT	
"4857781" "5107372" "5647311" "5724015" "6014240" "6054329").PN. stationary adj member 11 11915 stationary adj member USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO;	10	9	("3503022" "3619673" "4527139"	USPAT	2004/08/23 17:28
11] 10				
11 1915 stationary adj member					
13	11	11915		USPAT;	2004/08/23 17:36
13	1 - 1	11713		US-PGPUB;	
13				EPO; JPO;	
13				DERWENT	
14 3 ((electromagnetic adj actuator) and (movable adj member) and (stationary adj member)) and (silicon adj substrate) 12 25 (electromagnetic adj actuator) and (movable adj member) and (stationary adj member) 15 (221090 plating	13	114581	silicon adi substrate	USPAT;	2004/08/23 17:37
14 3 ((electromagnetic adj actuator) and (movable adj member) and (stationary adj member)) and (silicon adj substrate) 12 25 (electromagnetic adj actuator) and (movable adj member) and (stationary adj member) 15 221090 plating 16 69889 photolithography 17 7464 plating and photolithography DERWENT USPAT; US-PGPUB; EPO; JPO; D	15			US-PGPUB;	
14 3 ((electromagnetic adj actuator) and (movable adj member) and (stationary adj member)) and (silicon adj substrate) USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERW		<u> </u>		EPO; JPO;	
(electromagnetic adj actuator) and (stationary adj member) and (silicon adj substrate) 12 25 (electromagnetic adj actuator) and (movable adj member) and (stationary adj member) and (stationary adj member) 15 221090 plating 16 69889 photolithography 17 7464 plating and photolithography (refetchmagnetic adj actuator) and (stationary adj member) and (stationary adj member) EPO; JPO; DERWENT US-PGPUB; EPO; JPO; DERWE		1		DERWENT	
(movable adj member) and (stationary adj member)) and (silicon adj substrate) 12 25 (electromagnetic adj actuator) and (movable adj member) and (stationary adj member) 15 221090 plating 16 69889 photolithography 17 7464 plating and photolithography (movable adj member) and (stationary adj member) and (stationary adj member) 18 221090 plating (alectromagnetic adj actuator) and (spath with the property of	14	3	((electromagnetic adj actuator) and	USPAT;	2004/08/23 17:37
member)) and (silicon adj substrate) 12	4 3		(movable adj member) and (stationary adj	US-PGPUB;	
12 25			member)) and (silicon adj substrate)	EPO; JPO;	
12				DERWENT	
(movable adj member) and (stationary adj member) 221090 plating plating photolithography 7464 plating and photolithography (movable adj member) and (stationary adj EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	12	25	(electromagnetic adj actuator) and	USPAT;	2004/08/23 18:04
member) 221090 plating plating plating 221090 plating plating photolithography photolithography photolithography photolithography plating and phot	1.2		(movable adi member) and (stationary adj	US-PGPUB;	
DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;				EPO; JPO;	
15				DERWENT	
US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; USPAT; US-PGPUB; EPO; JPO; US-PGPUB; EPO; JPO;	15	221090	plating	USPAT;	2004/08/23 18:05
DERWENT USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT; U	10	221030		US-PGPUB;	
16 69889 photolithography 16 USPAT; US-PGPUB; EPO; JPO; DERWENT USPAT;		1		EPO; JPO;	
16 US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO; US-PGPUB; EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;			1	DERWENT	
17 Table 1	16	69889	photolithography	USPAT;	2004/08/23 18:05
7464 plating and photolithography The proof of the proof	10		F	US-PGPUB;	
7464 plating and photolithography The proof of the proof	1			EPO; JPO;	į
US-PGPUB; EPO; JPO;				ł	
US-PGPUB; EPO; JPO;	17	7161	plating and photolithography	USPAT;	2004/08/23 18:05
EPO; JPO;	1 /	1404	bracking and brocorrendants	·	

				0004/00/00
18	3	(plating and photolithography) and (stationary adj member) and (silicon adj substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/23 18:06
19	22	(plating and photolithography) and (electromagnetic adj actuator)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/23 18:25
20 21	2 4	("4421381" "5378653").PN. ("4421381" "4937226" "5116457"	USPAT USPAT	2004/08/23 18:07 2004/08/23 18:13
22 23	2 4	"5767666").PN. ("4421381" "5378653").PN. ("4421381" "4937226" "5116457"	USPAT USPAT	2004/08/23 18:13 2004/08/23 18:14
24	4	•	USPAT	2004/08/23 18:16
25	194	"5767666").PN. 29/595.ccls.	USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:26
26	3012	29/596.ccls.	DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:26
27	4	29/595.ccls. and 29/596.ccls.	DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:26
28	483	324/97.ccls.	DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:26
29	1782	324/96.ccls.	DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:27
30	16	324/97.ccls. and 324/96.ccls.	DERWENT USPAT; US-PGPUB;	2004/08/23 18:27
31	240	335/256.ccls.	EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:27
32	584	335/220.ccls.	DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:27
33	3	335/256.ccls. and 335/220.ccls.	DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:30
34	26	334/2.ccls.	DERWENT USPAT; US-PGPUB;	2004/08/23 18:29
35	584	335/220.ccls.	EPO; JPO; DERWENT USPAT; US-PGPUB;	2004/08/23 18:29
36	2	6124923.pn.	EPO; JPO; DERWENT USPAT; US-PGPUB;	2004/08/23 18:31
37	2	4752757.pn.	EPO; JPO; DERWENT USPAT; US-PGPUB; EPO; JPO;	2004/08/23 18:31
			DERWENT	

38	2	6054329.pn.	USPAT; US-PGPUB;	2004/08/23 18:32
			EPO; JPO;	
			DERWENT	
39	4	4421381.pn.	USPAT;	2004/08/23 18:32
		•	US-PGPUB;	
			EPO; JPO;	
1			DERWENT	